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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10087982	FILING DATE 03/05/2002	CLASS 438	SUBCLASS 345.24	GAU 2842	EXAMINER Mills
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****APPLICANTS:** Tanaka Junichi; Masuda Toshio; Kagoshima Akira; Ikuhara Shoji;
Yamamoto Hideyuki;

156 1763
plasma apparatus

****CONTINUING DATA VERIFIED:**

**** FOREIGN APPLICATIONS VERIFIED:**

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

500.41371X00

TITLE: Data processing apparatus for semiconductor processing apparatus

U.S. DEPT. OF COMM./PAT. & TM.-PTO-438L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Applicant Examiner	
		PREPARED FOR ISSUE	
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